



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q65781

Hiroyuki NAGASAWA

Appln. No.: 09/924,872

Group Art Unit: 2812

Confirmation No.: 3695

Examiner: Savitri MULPURI

Filed: August 09, 2001

For: SILICON CARBIDE AND METHOD OF MANUFACTURING THE SAME

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP NON-FEE AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 3, 2003, please amend the above-identified application as follows on the accompanying pages.

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